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Substitute for form 1449A/PTO		<b>Complete if Known</b>	
<b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</b> <i>(use as many sheets as necessary)</i>		Application Number	10/733,352
		Filing Date	December 12, 2003
		First Named Inventor	Shunpei YAMAZAKI et al.
		Group Art Unit	2812
		Examiner Name	S. Isaac
Sheet 1 of 4	Attorney Docket Number	0756-7227	

U.S. PATENT DOCUMENTS						
Examiner Initials <sup>1</sup>	Cite No. <sup>1</sup>	U.S. Patent Document		Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number	Kind Code <sup>2</sup> (if known)			
SBI		2001/0034088		Nakamura et al.	10/25/2001	
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		Office <sup>3</sup>	Number <sup>4</sup>	Kind Code <sup>2</sup> (if known)				
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Examiner Initials <sup>1</sup>	Cite No. <sup>1</sup>	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T <sup>3</sup>
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SBI		L.S. LEE et al., <i>Argon Ion-Implantation on Polysilicon or Amorphous-Silicon for Boron Penetration Suppression in p+ pMOSFET</i> , IEEE Transactions on Electron Devices, Vol. 45, No. 8, August, 1998, Pages 1737-1744.	

Examiner Signature	<i>Stanetta Baac</i>	Date Considered	12/26/05
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		Specification, claims, abstract of Application Serial No. 08/784,293 filed January 16, 1997 to Yamazaki et al.	

Examiner Signature	<i>Shanetta L. Gage</i>	Date Considered	12/26/05
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